



PATENT
81790.0211

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Koichi GEN-EI et al.

Serial No: 09/954,475

Filed: September 14, 2001

For: SEMICONDUCTOR LASER WHICH
REMOVES INFLUENCES FROM
RETURNING LIGHT OF THREE
BEAMS AND METHOD OF
MANUFACTURING THE SAME

Date of NOA: May 20, 2004

Art Unit: 2828

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Date of Deposit

Firoozeh Vakilzadeh

Name

Firoozeh Vakilzadeh

Signature

8/19/04

Date

TRANSMITTAL OF ISSUE FEE

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Dear Sir:

In response to the Notice of Allowance dated May 20, 2004, enclosed are the following:

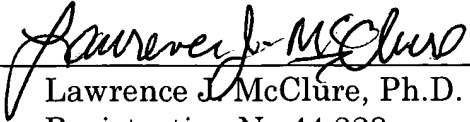
- ☒ Form Part B - Issue Fee Transmittal and a check in the amount of \$ 1,660.00 in payment of the Issue Fee, Publication Fee, and Advance Order for 10 patent copies (at \$3.00 per copy).
- ☒ Formal Drawings are being filed concurrently with the Official Draftsman.

The Commissioner is hereby authorized to charge any deficiency in payment or credit any overpayment to Deposit Account No. 50-1314. A copy of this Transmittal is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: August 19, 2004

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